



Attorney's Docket No.: 004085.P039

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Patent Application of: )  
Toshiyuki Max Saito )  
Application No.: 10/761,678 )  
Filed: January 20, 2004 )  
For: IMPRINT EMBOSSING SYSTEM )  
Examiner: Not yet assigned  
Art Unit: Not yet assigned

Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

**Cross Reference Under 37 C.F.R. § 1.78(a)(2) to Related Applications**

Dear Sir:

Pursuant to 37 C.F.R. § 1.78(a)(2), applicant hereby cross-reference the following related patent applications, which are assigned to the same assignee as the above-identified present patent application:

U.S. Patent Application No. 10/761,486 filed on January 20, 2004, entitled "Isothermal Imprint Embossing System";

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria, Virginia 22313-1450 on:

February 11, 2004  
Date of Deposit

Dianne Neathery  
Name of Person Mailing Correspondence

*Dianne Neathery*  
Signature

February 11, 2004  
Date

U.S. Patent Application No. 10/761,464 filed on January 20, 2004, entitled  
"Imprint Embossing Alignment System"; and

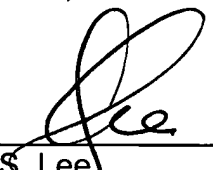
U.S. Patent Application No. 10/659,006 filed on September 9, 2003, entitled  
"Isothermal Imprinting".

If there are any charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: February 11, 2004

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